PTO/SB/21 (08-03)

Approved for use through 07/31/2006. OMB 0651-0031

U.S. Patent and Trademark Office: U.S. DEPARTMENT OF COMMERCE

Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it displays a valid OMB control number. Application Number 09/957,443 Filing Date TRANSMITTAL September 18, 2001 First Named Inventor FORM Jason Zweiback Art Unit 2872 (to be used for all correspondence after initial filing) Examiner Name J. Pritchett Attorney Docket Number 5 Total Number of Pages in This Submission 64626/P001CP1/10302976 ENCLOSURES (Check all that apply) After Allowance Communication Fee Transmittal Form Drawing(s) to Group Appeal Communication to Board of Fee Attached Licensing-related Papers Appeals and Interferences Appeal Communication to Group Amendment/Reply Petition (Appeal Notice, Brief, Reply Brief) Petition to Convert to a After Final Proprietary Information Provisional Application Power of Attorney, Revocation Affidavits/declaration(s) Status Letter Change of Correspondence Address Other Enclosure(s) (please identify below): Terminal Disclaimer Extension of Time Request PTO/SB/08A Express Abandonment Request Request for Refund

x Information	n Disclosure Statement	CD, Number of CD(s)	9 cited references Return Postcard
Document	opy of Priority (s)		
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	SIGNATI	JRE OF APPLICANT, ATTORNEY, OF	RAGENT
Firm or Individual name	FULBRIGHT & JAW Michael & Papalas	ORSKI L.L.P.	IL ROOK
Signature			
Date	September 3, 2003		

	Transmittal
	ence is being deposited with the U.S. Postal Service with sufficient postage as First Class Mail, in an iner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date shown below.
Dated: September 3, 2003	Signature:(Rita Carr)



Docket No.: 64626/P001CP1/10302976 (PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Jason Zweiback, et al.

Application No.: 09/957,443

Filed: September 18, 2001

For: LITHOGRAPHIC METHOD FOR

MANUFACTURING A MASK USED IN THE FABRICATION OF A FIBER BRAGG

GRATING

Art Unit: 2872

Examiner: J. Pritchett

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT (IDS)

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

In accordance with 37 CFR 1.97, Applicant(s) hereby make of record the following additional documents. A PTO Form SB/08 and a full copy of each of these documents accompany this statement.

Applicant(s) have become aware of the following documents, cited in a Communication Relating to the Results of the Partial International Search, which was mailed August 20, 2003, during the prosecution of international application no. PCT/US01/29178, which corresponds to the above referenced application, and in accordance with 37 CFR 1.97(c) and (e)(1) or (b)(3), hereby submit(s) these documents for the Examiner's consideration. These documents are cited on the enclosed PTO Form SB/08, and a copy of the International Search Report and each document cited thereon are enclosed as well.

This statement is not to be interpreted as a representation that the cited documents are material, that an exhaustive search has been conducted, or that no other relevant information exists. Nor shall the citation of any document herein be construed *per se* as a representation

Application No.: 09/957,443 Docket No.: 64626/P001CP1/10302976

that such document is prior art. Moreover, Applicant(s) understand(s) the Examiner will make an independent evaluation of the cited documents.

The undersigned hereby certifies that each item contained in this Supplemental Information Disclosure Statement was cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this Information Disclosure Statement. Furthermore, in accordance with 37 CFR 1.704(d), Applicant(s) note(s) that to our knowledge this communication was not received by any individual designated in 1.156(c) more than thirty days prior to the filing of this statement.

Applicant believes no fee is due with this response. However, if a fee is due, please charge our Deposit Account No. 06-2380, under Order No. 64626/P001CP1/10302976 from which the undersigned is authorized to draw.

Dated: September 3, 2003

Respect fully mitted,

Michael A. Papalas

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PTO/SB/08A (10-01)

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Substitute for form 1449A/PTO				Complete if Known		
				Application Number	09/957,443	
11	VFORMATIOI	N DI	SCLOSURE	Filing Date	September 18, 2001	
5	STATEMENT	BY A	APPLICANT	First Named Inventor	Jason Zweiback	
	(use as many sheets as necessary)			Art Unit	2872	
				Examiner Name	J. Pritchett	
Sheet	1	of	1	Attorney Docket Number	64626/P001CP1/10302976	

			U.S. PATE	ENT DOCUMENTS	
Examiner Initials*	Cite No.1	Document Number Number-Kind Code ² (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevent Passages or Relevant Figures Appear
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FOREIGN PATENT DOCUMENTS								
Examiner Initials*	Cite No.1	Foreign Patent Document Country Code ³ -Number ⁴ -Kind Code ⁵ (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	1		
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^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant

¹ Applicant's unique citation designation number (optional). ² See attached Kinds Codes of USPTO Patent Documents at www.uspto.qov or MPEP 901.04. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the application number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

		NON PATENT LITERATURE DOCUMENTS			
Examiner Initials	Cite No.1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc), date, page(s), volume-issue number(s), publisher, city and/or country where published.			
	CA	Albert, J. et al., "Minimization of Phase Error in Long Fiber Bragg Grating Phase Masksmade Using Electron Beam Lithography," IEEE Photonics Technology Letters, IEEE Inc., New York, US, October 1, 1996, vol. 8, no. 10, pp. 1334-1336			
	СВ	Tiberio, R.C. et al., "Fabrication of electron beam generated, chirped, phase mask (1070.11-1070.66nm) for fiber Bragg grating dispersion compensator," Journal of Vacuum Science and Technology: Part B, November 1998, vol. 16, no. 6, pp. 3237-3240			
	СС	Chakarian, V. et al., "System architecture choices for an advanced mask writer (100-130 nm)," Proceedings of the SPIE, September 1999, vol. 3873, pp. 1-15			
	CD	Morgante, C.G., et al., "The ALTA 3700: Extending the Application Space of the ALTA 3500 Laser Recticle Writer," Proceedings of the SPIE, April 2000, vol. 4066, pp. 1-11			
	CE	Rishton S.A. et al., "Raster shaped beam pattern generation," Journal of Vacuum Science and Technology: Part B, American Institute of Physics, New York, US, November 1999, vol. 17, no. 6, pp. 2927-2931			
	CF	Pfeiffer H.C., et al., "EL-4, A New Generation Electron-Beam Lithography System," Journal of Vacuum Science and Technology: Part B, American Institute of Physics, New York, US, November 1, 1993, vol. 11, no. 6, pp. 2332-2341			
	CG	Hill, K.O., et al., "Fiber Bragg Grating Technology Fundamentals and Overview," Journal of Lightwave Technology, August 1997, vol. 15, no. 8, pp. 1263-1276			
	СН	Ericksson, U. et al., "Design of Fiber Gratings For Total Dispersion Compensation," Optics Letters, Optical Society of America, Washington, US, July 15, 1994, vol. 19, no. 14, pp. 1028-1030			
	CI	Communication Relating to the Results of the Partial International Search, PCT/US01/29178, mailed August 20, 2003			

^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Examiner	Date	
Signature	Considered	
		

¹Applicant's unique citation designation number (optional). ²Applicant is to place a check mark here if English language Translation is attached.